

October 9, 2024

Description

Measurements

Carat Weight

Color Grade

Clarity Grade

Fluorescence

Inscription(s)

process.

Type IIa

Cut Grade

Polish Symmetry

GRADING RESULTS

IGI Report Number

Shape and Cutting Style

ADDITIONAL GRADING INFORMATION

Comments: This Laboratory Grown Diamond was

GEMOLOGICAL INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

56% _ 33.9° 14.5% \square 40.9° 43%

LG657460945

Report verification at igi.org

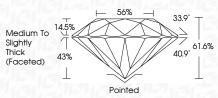


Sample Image Used

LABORATORY GROWN DIAMOND REPORT

October 9, 2024

LG657460945	IGI Report Number
LABORATORY GROWN DIAMOND	Description
style ROUND BRILLIANT	Shape and Cutting St
6.50 - 6.53 X 4.01 MM	Measurements
S	GRADING RESULTS
1.04 CARAT	Carat Weight
D	Color Grade
VVS 2	Clarity Grade
IDEAL	Cut Grade



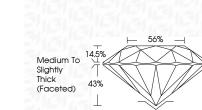
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	(G) LG657460945
Comments: This Laboratory created by Chemical Vapo process. Type IIa	Grown Diamond was or Deposition (CVD) growth

COLOR

DEF	GHIJ	Faint	Very Light	Light
CLARITY	WS ¹⁻²	VS ¹⁻²	SI ¹⁻²	1-3
Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included
OI ©	l 2020, International Ge	emological Institute		FD - 10 20

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	LAOLLLI
nmetry	EXCELLE
prescence	NOM
cription(s)	1671 LG6574609
mments: This Laboratory (ated by Chemical Vapo acess. ae IIa	Grown Diamond was r Deposition (CVD) growtł





Medium To Slightly Thick (Faceted)

PROPORTIONS

LG657460945

1.04 CARAT

D

VVS 2

IDEAL

EXCELLENT

EXCELLENT

131 LG657460945

NONE

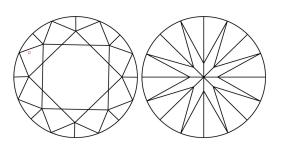
ROUND BRILLIANT

6.50 - 6.53 X 4.01 MM

LABORATORY GROWN DIAMOND

61.6% Pointed

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics. Green symbols indicate external characteristics.

created by Chemical Vapor Deposition (CVD) growth

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